



Docket No.: 060188-0578

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
: Confirmation Number: 4939  
Shinichi IMAI, et al. :  
Application No.: 10/619,191 : Group Art Unit: 2125  
Filed: July 15, 2003 : Examiner: Maria N. Von Buhr  
:

For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION  
APPARATUS

**AMENDMENT UNDER 37 CFR § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are submitted under 37 CFR § 1.111 in response  
to the non-final Office Action mailed June 21, 2006.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 6.